

Notice of References Cited	Application/Control No. 10/750,554	Applicant(s)/Patent Under Reexamination NAVADA ET AL.	
	Examiner Van Kim T. Nguyen	Art Unit 2152	Page 1 of 1

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*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A US-6,463,067	10-2002	Hebb et al.	370/413
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NON-PATENT DOCUMENTS

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